



I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO: COMMISSIONER for PATENTS, P. O. Box 1450, Arlington, VA 22313-1450.

8/19/03
(Date of Deposit)

Karen Cinq-Mars (Signature & Date)

Karen Cinq-Mars 8/19/03

#16
200
950

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of _____ :

August 19, 2003

Caroline Boulenger _____ :

Art Unit: 2822

Serial No. 09/756,997 _____ :

Examiner: Christy L. Novacek

Filed: January 8, 2001 _____ :

IBM Corporation
Dept. 18G/Bldg. 300-482
2070 Route 52,
New York 12533-6531

Title: METHOD FOR ELIMINATING
DEVELOPMENT RELATED DEFECTS
IN PHOTORESIST MASKS _____ :

RECEIVED
AUG 26 2003
TECHNOLOGY CENTER 2800

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Arlington, Va 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 CFR 1.56, and further pursuant to 37 CFR 1.97 and 37 CFR 1.98, Applicants hereby respectfully submit copies of the following documents as listed on Form PTO-1449, attached hereto.

Please charge any fees in connection with this statement to Deposit Account # 09-0458.

Respectfully submitted,

Joseph P. Abate 8-19-03
Joseph P. Abate, Attorney
Registration No. 30,238
Telephone No. (845)894-4633

JPA/kcm

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